IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: TAKEUCHI et al.

Examiner:

unknown

Serial No.:	unknown	Group Art Unit:	unknown			
Filed:	Concurrent herewith	Docket:	14434.0103USWO			
Title:	Title: FIELD-EFFECT TRANSISTOR, METHOD OF MANUFACTURING THE SAME, AND ELECTRONIC DEVICE USING THE SAME					
CERTIFICATE OF I hereby certify that Box 1450, Alexand By: Name: NICOLE L	TRANSMISSION t the papers listed below are being transmitted by EFS trig VA 22313-455 or OCTOBER 4, 2006. ANDREE	Web to: Mail Stop PCT, Co	mmissioner for Patents, P.O.			
	INFORMATION DISCLOS	URE STATEMEN	<u> </u>			
P.O. Box 14:	er for Patents					
Sir:						
the enclosed	regard to the above-identified applic Form 1449 are brought to the attenti at documents or "Other Documents"	ion of the Examiner				
other inform	ncise explanation of the relevance of ation is as follows (37 C.F.R. §1.98(100-260999 corresponds to U.S. 6,18	a)(3)):	anguage document or			
In acc (CHECK ON	cordance with the provisions of 37 C NE):	.F.R. §1.97, this sta	atement is being filed			
O:	within three (3) months of the Filing ffice Action on the merits, or before ction on the merits after the filing of order 37 C.F.R. §1.114; or	the mailing date of	a First Office			
	after the period defined in (1) but be ejection or Notice of Allowance, and		e of a Final			
the	e requisite Statement is below, OR					
the	e requisite fee of \$180.00 under Rule	1.17(p) is included	l herein, or			
	after the mailing date of a Final Reje fore the payment of the Issue Fee, A		Allowance but on or			

	the r	equisite Statement is	below, AND	
	the r	equisite fee of \$180.0	00 under Rule 1.17(p) is in	cluded herein.
			STATEMENT	
A	s requ	uired under §1.97(e),	Applicants hereby state eit	ther that:
	1.	Statement was first in a counterpart fore	ation contained in the Info cited in a communication f ign application not more t Information Disclosure S	from a foreign patent office han three months prior to
	2.	Statement was cited counterpart foreign signing this Stateme information contain known to any indivi	ion contained in the Information a communication from application, and to the knot after making reasonable and in the Information Discussional designated in §1.56(c) the Information Disclosur	a foreign patent office in a wledge of the person enquiry, no item of losure Statement was by more than three months
If th	is bo	x is checked, Applica	nt provides the following:	
		Certification	n Under 37 C.F.R. §1.70	<u>4(d)</u>
item forei not i	liste ign pa receiv	d on the cnclosed For atent office in a count red by any individual	\$1.704(d), the undersigned m 1449 was first cited in a terpart application, and tha designated in 37 C.F.R. § this Information Disclosur	t this communication was 1.56(c) more than thirty
 of e	ach U		ed of the following co-pend a publication (if published)	
	App	lication No.	Filing Date	Group

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested that the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

FEE AUTHORIZATION

Should any fee associated with the submission of this paper not be attached hereto as a check, the Commissioner is authorized to charge the missing fee to our Deposit Account, No. 50-3478. Any overpayments should be credited to said Deposit Account.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER & LARSON, P.C. Post Office Box 2902 Minneapolis, MN 55402-0902 (612) 455-3800

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DPM:nel

Date Mailed: OCTOBER 4, 2006 Sheet 1 of 1

FORM 1449*	INFORMATION DISCLOSURE STATEMENT	Docket Number: 14434.103USWO	Application Number: UNKNOWN		
	IN AN APPLICATION	Applicant: TAKEUCHI et al.	Applicant: TAKEUCHI et al.		
	(Use several sheets if necessary)	Filing Date: concurrent herewith	Group Art Unit: UNKNOWN		

		U	S. PATENT DOCUMENTS				
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME CLASS		SUBCLASS	FILING DATE IF APPROPRIATE	
	2005/0079659	4.14.05	DUAN et al.				
	2005/0056828	3.17.05	WADA et al.				
	6,108,956	1.30.2001	CHONDROUDIS et al.				-
		FOR	EIGN PATENT DOCUMEN	T\$		<u> </u>	
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	2004/032193	15.04.2004	WIPO				
	2004-111870	2004.04.08	JP			ABSTRACT	
	2004-067413	2004.03.04	JP			ABSTRACT	
	2000-260999	2000.09.22	JP			SEE IDS	
	OTHER	DOCUMENTS	6 (Including Author, Title, Date	e, Pertinent F	ages, Etc.)		
	Duan et nanorib	al., High-peri bons, Nature	formance thin-film transi Vol. 425, September 18, 2	stors using 2003, pp. 2	semiconducto 274-278 *	or nanowires a	nd
			ablation method for the sy pary 9, 1998, pp. 208-211		crystalline sem	iconductor nan	owires
			racteristics of silicon nano mplates, Journal of Crystal				owth i
			and transport properties Applied Physics Letters				-4178

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EXAMINER	DATE CONSIDERED	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of Ihis form for next communication to the Applicant